

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Atsushi MURAKOSHI et al.

Serial No.: 09/559,345

Filed: April 27, 2000



Group Art Unit: 2878

Examiner: Not Assigned

For: ION GENERATION METHOD AND FILAMENT FOR ION GENERATION APPARATUS

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

The following is a concise statement of relevance of the non-English language documents:

1. Japanese Patent Application No. 10-188833, discloses sputtering ion implantation technology wherein a material plate is detachably held on a slit formed along the inner wall of the arc chamber.

2. Japanese Patent Application No. 03-013576, discloses an ionize vaporization system using Iodine - Indium (InI).

An English-language abstract of each of the non English-language documents is also enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: _____

Richard V. Burgujian
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Dated: August 23, 2000
Enclosures
RVB/FPD/sci

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